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PATENT & TRADEMARK OFFICE

PATENT
Atty. Dkt. No. AMAT/2922/ETCH/DRIE/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Rozenzon, et al.

Serial No.: 09/325,026

Confirmation No.: 2304

Filed: June 3, 1999

For: TEMPERATURE CONTROLLED WINDOW WITH A FLUID SUPPLY SYSTEM

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§ Group Art Unit: 1763
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§ Examiner: Alejandro-Mulero, L
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CERTIFICATE OF MAILING
37 CFR 1.8
I hereby certify that this correspondence is being deposited on October 9, 2001 with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

10/11/01
Date

Keith M. Tackett, Reg. No. 32, 008

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

RESPONSE TO OFFICE ACTION DATED JULY 6, 2001

In response to the Office Action dated July 6, 2001, having a shortened statutory period for response set to expire on October 9, 2001, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below.

IN THE SPECIFICATION:

Please replace the paragraph at page 6, line 21, to page 7, line 5, with the following paragraph:

Figure 1 is a cross sectional view of one embodiment of an etch chamber 2 of the present invention having a generally flat lid assembly 8, including an energy transparent window 48. The chamber 2 generally includes an annular sidewall 4, a bottom wall 6, and a lid assembly 8. A pedestal 18 operating as a cathode is disposed in the lower